

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
RD-28,694SERIAL NO.
10/064,888INFORMATION DISCLOSURE STATEMENT BY APPLICANT
LIST OF ITEMSApplicant
Marc (NMN) Schaepkens et al.Filing Date
8/27/02Group
1763

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MET	A1 6,110,544	8/29/00	Yang et al.			
MJG	A2 6,261,694	7/17/01	Iacovangelo			
MWZ	A3 6,376,064	4/23/02	Gasworth et al.			
MJG	A4 6,397,776	6/4/02	Yang et al.			
MJG	A5 6,420,032	7/16/02	Iacovangelo			
MJG	A6 6,426,125	7/30/02	Yang et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	NO
B1							
B2							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

C1	Application RD-25,955, Serial No. 09/271,656, filed March 17, 1999
C2	Application RD-28,484, Serial No. 09/683,148, filed November 27, 2001
C3	
C4	
C5	
C6	
C7	
C8	

EXAMINER

Maureen J. Francis

DATE CONSIDERED

03/29/2006

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

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AUG 04 2005

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
RD-28,694-1SERIAL NO.
10/064,888

**SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT BY APPLICANT
LIST OF ITEMS**

Applicant
Marc Schaepkens et al.Filing Date
8/27/02Group
1753 1763**U.S. PATENT DOCUMENTS & U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>MSC</i>	A1 6,093,903	7/25/00	Schneider			
<i>MSC</i>	A2 2003/0099784	5/29/03	Schaepkens			
<i>MSC</i>	A3 2003/0121887	7/3/03	Garvey et al.			
<i>MSC</i>	A4 2004/0040833	3/4/04	Schaepkens et al.			
	A5					
	A6					
	A7					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>MSC</i>	B1 EP 0 249 238	12/16/87	European			X
	B2					
	B3					
	B4					
	B5					
	B6					

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

<i>MSC</i>	C1	M. Schaepkens et al., "High-Rate Deposition of Abrasion Resistant Coatings Using a Dual-Source Expanding Thermal Plasma Reactor", American Vacuum Society, Journal of Vacuum Science and Technology A, Volume 21, No. 4, pp. 1266-1271, 2003.
<i>MSC</i>	C2	International Search Report dated June 24, 2005.
	C3	
	C4	
	C5	

EXAMINER

Manneen R. Chanci

DATE CONSIDERED

03/29/2006

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